

<b>Notice of References Cited</b>	Application/Control No. 10/519,949		Applicant(s)/Patent Under Reexamination ZANELLA ET AL.	
	Examiner Jeff H. Aftergut		Art Unit 1791	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,605,171	08-2003	Debalme et al.	156/172
*	B	US-4,680,224	07-1987	O'Connor, James E.	428/298.1
*	C	US-5,055,242	10-1991	Vane, Jeffrey A.	264/463
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP-2001-113550-A	04-2001	JAPAN	--	--
	O	WO-00/47397-A1	08-2000	PCT	--	--
	P	UK-2,041,489-A	09-1980	UNITED KINGDOM	--	--
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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